

# SLPC2026 SESSION CHART (Tentative as of Feb. 18)

Time	Day-1: APRIL 21 (Tue)	Day-2: APRIL 22 (Wed)	Day-3: APRIL 23 (Thu)	Time
8:30		SLPC Committee Breakfast Meeting Room 422 (7:40-8:40)		8:30
		Break		
9:00	Opening Remark 9:00-9:05	Session 5	Session 8	9:00
9:30	Session 1	Transparent Materials	Laser Manufacturing	9:30
	Direct Energy Deposition 9:05-10:25 Room 311+312	9:00-10:35 Room 311+312	9:00-10:30 Room 311+312	10:00
10:30	Coffee Break	Break without coffee	Coffee Break	10:30
11:00	Session 2	Session P	Session 9	11:00
	Additive Manufacturing/ Selective Laser Melting 1 10:45-11:50 Room 311+312	Poster Session & Exhibitions 10:30-12:00 Exhibition Hall A *Poster Session Lunch Time 11:50-12:50	Femtosecond Laser Processing 10:45-12:00 Room 311+312	11:30
12:00	Lunch Time	Lunch Time	Lunch Time	12:00
12:30				12:30
13:00	Session 3	Session 6	Session 10	13:00
	Surface modification 1 13:30-14:50 Room 311+312	Beam Shaping 13:30-14:35 Room 311+312	Short pulse & UV Laser Processing 13:00-14:35 Room 311+312	13:30
14:30				14:30
15:00	Coffee Break	Coffee Break	Awards Ceremony and Closing Remark of SLPC2026 14:35-15:15 Room 311+312	15:00
15:30	Session 4	Session 7		15:30
	SLPC Plenary Session 15:30-17:30 Room 311+312	Surface Modification 2 15:10 -16:00, Room 311+312		16:00
16:30		Break without coffee		16:30
17:00		OPIC 2026 Plenary Session (Room 501+502)		17:00
17:30	Break without coffee			17:30
18:00	SLPC2026 Reception at Bay Bridge Café (6th floor of the venue) 18:00-20:00			18:00
18:30				18:30
19:00	*Free invitation exclusively for SLPC attendees			19:00
19:30		OPIC2026 Banquet (19:15-) Room 301 + 302 + 304 <small>*Required to pay banquet tickets in advance</small>		19:30